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## APPLICANTS

Hiroshi Okumura, Tokyo, JAPAN;

\*\* CONTINUING DATA \*\*\*\*\*

none. *[Signature]* 03/06/05

\*\* FOREIGN APPLICATIONS \*\*\*\*\*

JAPAN 042083/2003 02/20/2003

in file. *[Signature]* 03/06/05

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

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Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY JAPAN	SHEETS DRAWING 8	TOTAL CLAIMS 28	INDEPENDENT CLAIMS 3
35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged Examiner's Signature <i>[Signature]</i> Initials <i>[Initials]</i>				

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## TITLE

Thin film transistor substrate and method for manufacturing the same

FILING FEE

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914

FEES: Authority has been given in Paper  
 No. \_\_\_\_\_ to charge/credit DEPOSIT ACCOUNT  
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